

10/586165

AP20 Rec'd PCT/PTO 14 JUL 2008 PATENT 42008-05892

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicants: Mitsuhiro SHIKIDA et al.  
International Application No.: PCT/JP2005/000633  
International Filing Date: January 13, 2005  
For: CHEMICAL ANALYTIC APPARATUS AND  
CHEMICAL ANALYTIC METHOD

745 Fifth Avenue  
New York, NY 10151

**EXPRESS MAIL**

Mailing Label Number: EV195879488US

Date of Deposit: July 14, 2006

I hereby certify that this paper or fee is being deposited with the United States Postal Service "Express Mail Post Office to Addressee" Service under 37 CFR 1.10 on the date indicated above and is addressed to Mail Stop PCT, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

Barnet Shikida  
(Typed or printed name of person mailing paper or fee)

Barnet Shikida  
(Signature of person mailing paper or fee)

**CLAIM OF PRIORITY**

Mail Stop PCT  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Pursuant to 35 U.S.C. 119, this application is entitled to a claim of priority to Application No. 2004-8415 filed in Japan on January 15, 2004.

Respectfully submitted,

FROMMER LAWRENCE & HAUG LLP  
Attorneys for Applicants

By: William S. Frommer  
William S. Frommer  
Reg. No. 25,506  
Tel. (212) 588-0800